

**Search Notes**

Application/Control No.

10/057,952

Examiner

David Y. Chung

Applicant(s)/Patent under  
Reexamination

NAKAYAMA ET AL.

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner
349	147	7/24/2006	DC
349	129	7/24/2006	DC
349	111	7/24/2006	DC
349	114	7/24/2006	DC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
same	same	7/24/2006	DC

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	9/16/2003	DC
EAST search report	9/10/2004	DC
EAST search report	7/24/2006	DC